

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Inventor: Moshe FINAROV

U.S. Patent Application No. 09/626,793

Filed: July 26, 2000

Confirmation No.8657

Group Art Unit: 2851

Examiner: David B. Esplin

For: APPARATUS FOR INTEGRATED MONITORING OF WAFERS AND FOR  
PROCESS CONTROL IN THE SEMICONDUCTOR MANUFACTURING AND A  
METHOD FOR USE THEREOF

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application and that the documents be made of record therein and appear among the "References Cited" on any patent to issue there from.

This Information Disclosure Statement is being filed under Rule 37 CFR 1.97(i), wherein applicants are submitting references before the grant of a patent to be placed in the file but not considered by the Patent Office. Accordingly, copies of the references as listed on the attached Form PTO-1449 are submitted herewith for placement in the file. No certification or fees are deemed necessary.

Respectfully submitted,

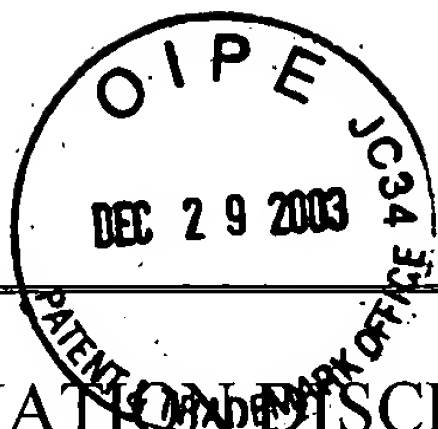
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<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION  (PTO-1449)</b>				ATTY. DOCKET NO. <b>1268-093A</b>		U.S. PATENT APPLICATION NO. <b>09/626,793</b>	
				APPLICANT <b>Moshe FINAROV</b>			
				FILING DATE <b>July 26, 2000</b>		GROUP <b>2851</b>	
<b>U.S. PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE	
	<b>5,486,701</b>	<b>01/1996</b>	<b>Norton et al.</b>				
	<b>5,943,122</b>	<b>08/1999</b>	<b>Holmes</b>				
	<b>6,278,519</b>	<b>08/2001</b>	<b>Rosencwaig et al.</b>				
<b>FOREIGN PATENT DOCUMENTS</b>							
EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No
	<b>63104873 A</b>	<b>05/1988</b>	<b>Japan</b>			<b>Abstract</b>	
	<b>02098955 A</b>	<b>04/1990</b>	<b>Japan</b>			<b>Abstract</b>	
	<b>11264072 A</b>	<b>09/1999</b>	<b>Japan</b>			<b>Abstract</b>	
<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)</b>							
EXAMINER				DATE CONSIDERED			

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.